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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Tatsuya Usami

Serial No.: 09/851,313 Group Art Unit: 2823

Filing Date: May 9, 2001 Examiner: Maldonado, Julio J.

For: SEMICONDUCTOR DEVICE AND SEMICONDUCTOR WAFER HAVING
MULTI-LAYERED INSULATION FILMCommissioner for Patents
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. All of these references were cited by the Examiner in the co-pending Application No. 10/135,393, in an Office Action dated May 2, 2005.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

I hereby certify that no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in § 1.56(c) more than three months prior to the filing of the information disclosure statement.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

Phillip E. Miller, Esq.
Registration No. 46,060

Date: 5/13/05

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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) NEC01P069-MSb	Application Number 09/851,313		
				Applicant(s) Tatsuya Usami			
				Filing Date May 9, 2001	Group Art Unit 2823		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	*REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	
		6,054,379	04/25/00	Yau et al.			
		6,812,131	11/02/04	Kennedy et al.			
		6,080,526	06/27/00	Yang et al.			
		6,197,703	03/06/01	You et al.			
		6,869,896	03/22/05	Cheung et al.			
		6,168,726	01/02/01	Li et al.			
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER				DATE CONSIDERED			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							